

APPLICATION DATA SHEET

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Attorney Docket Number: **740756-2440**

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Application Type:

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Title of Invention:

METHOD FOR FABRICATING THIN-FILM TRANSISTOR**Legal Representative:**

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22204**Continuity Data:**

This application is a division of 08/089,650 A1 1993-07-12 PENDING
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02-145069

JP

1990-06-01

Priority Claimed

Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd.

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